WCMNM2019: **3rd World Congress on Micro and Nano Manufacturing**

September 10th-12th 2019, Raleigh NC

Application for student travel /Registration Partial Support

Instructions

1. Who can apply: **Students currently studying in US institutions**
2. Read carefully and fill in every field on this form. The form consists of four sections, I: application information, II: participation, III: student statement featuring vision of micro or nano manufacturing, and IV: applicant resume
3. Complete the application form, get endorsement from your advisor, and then convert to a **single PDF** file for submission. Filename format is **WCMNM\_<Firstname>\_<Lastname>.pdf**. An example

**WCMNM\_Gracious\_Ngaile.pdf**

1. Submit the PDF file as an attachment in an email to Prof. Gracious Ngaile at email <[gngaile@ncsu.edu](mailto:gngaile@ncsu.edu)> with the subject line ***PARTIAL SUPPORT TO PARTICIPATE IN THE 3rd WCMNM2019***
2. Application due date is **June 20, 2019**. You will be acknowledged upon receiving the application
3. All applicants will be informed of the outcome by **July 1st** , **2019**
4. *This support will cover* ***hotel*** *(Raleigh Sheraton Hotel) for three days and* ***congress registration****.*

I: Application Information

|  |  |  |  |  |  |
| --- | --- | --- | --- | --- | --- |
| Student Name |  | Citizenship | | USA/Perm. Resident    Other | |
| Student ID number |  | | | | |
| School |  | | | | |
| Department |  | | | | |
| Student status | PhD student MS student BS student  Number of years in degree program | | | | |
| Email |  | | Phone | |  |
| Student’s Advisor |  | | | | |

II: Participation

|  |  |
| --- | --- |
| Check your author role | Lead author Co-author Multiple work submitted |
| Are you a presenting author? | Yes No |
| Underrepresented status | Check here if you are a member of a historically underrepresented group in  engineering (e.g., native american, african american, woman, disabled, etc.) |
| Research funding | Is the work you are presenting funded by the National Science Foundation (NSF)?  Yes No  If the answer is “Yes” provide NSF grant number |

III: Student Statement Featuring Vision of Micro-manufacturing or Nano-manufacturing

*Format: The statement should be written in the space below [Times New Roman, font size 11 and single spaced]*

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Applicant Name Applicant Signature Date

*I have read and attest to the truthfulness of this application*

\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_ \_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_ \_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_

Advisors name Advisor Signature Date

IV: Applicant Resume

Attach resume (maximum 2 pages) to this application